Optics EXPRESS

On-chip ultracompact multimode vortex beam emitter based on vertical modes: supplement

ZEYONG WEI,^{1,2,3,4} SHUQIAO LI,^{1,2,3,4} LINGYUN XIE,^{1,2,3,4,5,6,*} XIAO DENG,^{1,2,3,4} ZHANSHAN WANG,^{1,2,3,4} AND XINBIN CHENG^{1,2,3,4,7}

¹School of Physics Science and Engineering, Tongji University, Shanghai 200092, China
 ²Institute of Precision Optical Engineering, Tongji University, Shanghai 200092, China
 ³MOE Key Laboratory of Advanced Micro-Structured Materials, Shanghai 200092, China
 ⁴Shanghai Frontiers Science Research Base of Digital Optics, Tongji University, Shanghai 200092, China
 ⁵Department of Electronic Science and Technology, Tongji University, Shanghai 201804, China
 ⁶21310075@tongji.edu.cn
 ⁷chengxb@tongji.edu.cn

This supplement published with Optica Publishing Group on 21 September 2022 by The Authors under the terms of the Creative Commons Attribution 4.0 License in the format provided by the authors and unedited. Further distribution of this work must maintain attribution to the author(s) and the published article's title, journal citation, and DOI.

Supplement DOI: https://doi.org/10.6084/m9.figshare.21114442

Parent Article DOI: https://doi.org/10.1364/OE.473192

On-chip Ultracompact Multimode Vortex Beam Emitter Based on Vertical Modes: supplemental document

- This supplement contains:
- Note S1. Waveguide mode analysis simulation settings
- Note S2. TM_0 mode coupling structure parameters
- Note S3. TM_1 mode coupling structure parameters
- Note S4. Four-mode and five-mode vortex beam emitter structure parameters
- Note S5. Multimode resonant wavelengths alignment method
- Note S6. TM_1 and TM_2 mode coupling approach in five-mode vortex beam emitter
- Note S7. Discussion of grating element positions

1. NOTE S1. WAVEGUIDE MODE ANALYSIS SIMULATION SETTINGS

We analyze the waveguide modes by Lumeircal Mode Solutions. As shown in Figure 2(a), we build the Si waveguide on the SiO_2 substrate. The cross-sectional size of the small aspect ratio waveguide is 0.2 µm in height and 1.2 µm in width. The cross-sectional size of the large aspect ratio waveguide is 1.2 µm in height and 0.2 µm in width. The size of finite difference eigenmode solver (FDE) is $4 \times 4\mu m^2$ and the center of FDE is aligned with the waveguide center. The boundary conditions are all PML. The grid in FDE is $5 \times 5nm^2$.

2. NOTE S2. TM_0 MODE COUPLING STRUCTURE PARAMETERS

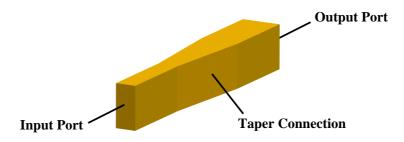
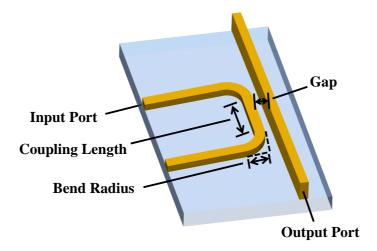


Fig. S1. Schematic diagram of TM_0 mode coupling structure.

Table S1. Parameter values of TM_0 mode coupling structure.

Waveguide	Input Port	Output Port	Connection	
Height [µm]	Waveguide Width [µm]	Waveguide Width [µm]	Length [µm]	
0.820	0.100	0.200	6.000	

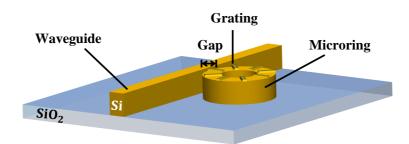


3. NOTE S3. TM_1 mode coupling structure parameters

Fig. S2. Schematic diagram of TM_1 mode coupling structure.

Input Port	Coupling	Bend
Waveguide Height [µm]	Length [µm]	Radius [µm]
0.399	4.000	1.500
Output Port	Waveguide	Gap
Waveguide Height [µm]	Width [µm]	[µm]
0.820	0.200	0.190

Table S2. Parameter values of TM_1 mode coupling structure.

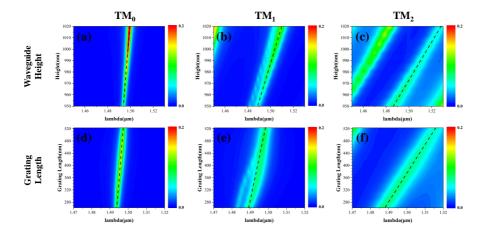


4. NOTE S4. FOUR-MODE AND FIVE-MODE VORTEX BEAM EMITTER STRUCTURE PARAMETERS

Fig. S3. Schematic diagram of the vortex beam emitter.

	Four-mode Emitter	Five-mode Emitter
Waveguide Width [µm]	0.200	
Waveguide Height [µm]	0.820	0.968
Microring Radius [µm]	1.500	
Grating Length [µm]	0.340	0.310
Grating Height [µm]	n] 0.100 0.150	
Gap [μm]		
Grating Number	15	

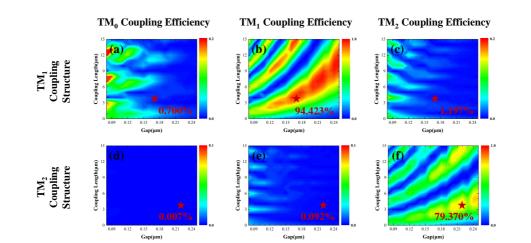
 Table S3. Parameter values of four-mode and five-mode vortex beam emitters.



5. NOTE S5. MULTIMODE RESONANT WAVELENGTHS ALIGNMENT METHOD

Fig. S4. Multimode resonant wavelengths adjustment method. (a)-(c) Varying the waveguide height, the resonant wavelength changes of TM_0 , TM_1 and TM_2 modes. (d)-(f) Varying the grating element length, the resonant wavelength changes of TM_0 , TM_1 and TM_2 modes.

As shown in Figure S4, when the waveguide height and grating element length are adjusted respectively, the variation range of resonant wavelengths of the three waveguide modes is different. For the same mode, the change of resonant wavelength caused by adjusting the height of waveguide is larger than that caused by adjusting the length of grating element. Therefore, in our design method , the waveguide height is firstly adjusted to achieve rough alignment of multimode resonant wavelengths. And then the grating element length is adjusted to achieve further alignment of resonant wavelengths. It is worth noting that the waveguide height should be adjusted to ensure that the waveguide is high enough to support the required waveguide modes, but not too high resulting in the introduction of higher order modes. Moreover, Figure S4 shows that the emission efficiency will also be affected when the resonant wavelengths alignment.



6. NOTE S6. TM_1 AND TM_2 MODE COUPLING APPROACH IN FIVE-MODE VORTEX BEAM EMITTER

Fig. S5. TM_1 and TM_2 mode coupling approach in five-mode vortex beam emitter. (a)-(c) TM_0 , TM_1 , TM_2 mode coupling efficiency of TM_1 coupling structure, when the wavelength is 1.49 µm. (d)-(f) TM_0 , TM_1 , TM_2 mode coupling efficiency of TM_2 coupling structure, when the wavelength is 1.49 µm.

The waveguide height in the five-mode vortex beam emitter is 968 nm. By effective index matching, the height of the input waveguide in the TM_1 mode coupling structure is 475 nm, and the height of the input waveguide in the TM_2 mode coupling structure is 300 nm. According to the parameter sweeps in Figure S5, it can be determined that the gap in the TM_1 coupling structure is 170 nm, and the coupling length is 4 µm. The coupling efficiency of TM_1 mode is 94.423% and the mode purity is 98.031%. The gap in the TM_2 coupling structure is 220 nm, and the coupling length is 4 µm. The coupling structure is 29.370% and the mode purity is 99.875%.

7. NOTE S7. DISCUSSION OF GRATING ELEMENT POSITIONS

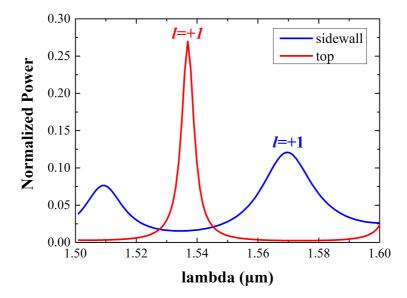


Fig. S6. Emission efficiency of the vortex beam emitter when the grating elements are placed in different positions

As shown in Figure S6, for TM_0 mode, the emission efficiency is about 12% when the grating elements are placed on the sidewall of the microring and about 27% when the grating elements are placed on top of the microring, so we choose to place the grating elements on top of the microring to improve the emission efficiency of the emitter.